



01-12-05

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Docket No.: 60675 (48229)
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Tetsumasa Sato

Application No.: 10/759,609

Confirmation No.: 8169

Filed: January 16, 2004

Art Unit: 2818

For: MANUFACTURING METHOD OF
SEMICONDUCTOR DEVICE

Examiner: Ho, Tu Tu V

RESPONSE TO RESTRICTION REQUIREMENT

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450


Dear Sir:

In response to the restriction requirement set forth in the Office Action mailed December 9, 2004, Applicant hereby provisionally elects claims Group 1 (claims 1-7, 16, 20 and 22) for continued examination.

It is not believed that a fee is required. However, if a fee is required you are hereby authorized and requested to charge/credit Deposit Account No. **04-1105**.

Respectfully submitted,

Dated: January 10, 2005
Customer No.: 21874

By 
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